

Application/Control No.	Applicant(s)/Patent unde Reexamination	Applicant(s)/Patent under Reexamination	
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Examiner	Art Unit		
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CEARCUED					
SEARCHED					
Class	Subclass	Date	Examiner		
514	. 218	4/14/2006	JMK		
514	220	4/14/2006	$ u_{JMK}$		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
inventor search	4/14/2006	JMK		
STN (registry; medicine): see attached search terms.	4/14/2006	JMK		
WEST	4/14/2006	ЈМК		
Transulation ordered Uki et al.	4/6/2006	<b>Ј</b> МК		
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